

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	732	438/778.ccls.	USPAT	OR	OFF	2005/02/23 19:00
L2	607	438/787.ccls.	USPAT	OR	OFF	2005/02/23 19:00
L3	436	438/788.ccls.	USPAT	OR	OFF	2005/02/23 19:00
L4	278	438/789.ccls.	USPAT	OR	OFF	2005/02/23 19:01
L5	316	438/790.ccls.	USPAT	OR	OFF	2005/02/23 19:01
L6	96	438/902.ccls.	USPAT	OR	OFF	2005/02/23 19:01
L7	246	438/905.ccls.	USPAT	OR	OFF	2005/02/23 19:02
L8	5	jang-bong\$.in.	USPAT	OR	OFF	2005/02/23 19:02
L9	4	jang-bong\$.in.	US-PGPUB	OR	OFF	2005/02/23 19:02
L10	4	jang-bong\$.in.	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/23 19:02
L11	8217	(wafer substrate) and (TEOS tetraort\$8) and (plasma RF (radio adj frequency))	USPAT	OR	OFF	2005/02/23 19:08
L12	4607	11 and ((TEOS tetraort\$8) same (plasma RF (radio adj frequency)))	USPAT	OR	OFF	2005/02/23 19:08
L13	2060	12 and (chamber reactor batch)	USPAT	OR	ON	2005/02/23 19:08
L14	4398	(wafer substrate) and (TEOS tetraort\$8) and (plasma RF (radio adj frequency))	US-PGPUB	OR	OFF	2005/02/23 19:07
L15	2067	14 and (chamber reactor batch)	US-PGPUB	OR	ON	2005/02/23 19:08
L16	451	(wafer substrate) and (TEOS tetraort\$8) and (plasma RF (radio adj frequency))	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/23 19:07
L17	468	(wafer substrate) and (TEOS tetraort\$8) and (plasma RF (radio adj frequency))	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/23 19:07
L18	4448	(wafer substrate) and (TEOS tetraort\$8) and (plasma RF (radio adj frequency))	US-PGPUB	OR	ON	2005/02/23 19:07
L19	2094	18 and (chamber reactor batch)	US-PGPUB	OR	ON	2005/02/23 19:08
L20	8327	(wafer substrate) and (TEOS tetraort\$8) and (plasma RF (radio adj frequency))	USPAT	OR	ON	2005/02/23 19:08
L21	3763	20 and (chamber reactor batch)	USPAT	OR	ON	2005/02/23 19:08
L22	2069	21 and ((TEOS tetraort\$8) same (plasma RF (radio adj frequency)))	USPAT	OR	ON	2005/02/23 19:09
L23	1817	22 and (clean\$6 remov\$6)	USPAT	OR	ON	2005/02/23 19:09
L24	1922	19 and (clean\$6 remov\$6)	US-PGPUB	OR	ON	2005/02/23 19:09